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Attorney Docket No. 0756-2222

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/699,466

Filed: October 31, 2000

For: METHOD FOR FABRICATING A
SEMICONDUCTOR DEVICE

) Group Art Unit: 2829

) Examiner: A. Sarkar

) CERTIFICATE OF MAILING) I hereby certify that this correspondence is
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SUPPLEMENTAL AMENDMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the
above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 11 of this paper.

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